

# Winfried MÃ¶nch

## List of Publications by Year in descending order

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45  
papers

2,718  
citations

257101

24  
h-index

301761

39  
g-index

46  
all docs

46  
docs citations

46  
times ranked

2368  
citing authors

#	ARTICLE	IF	CITATIONS
1	Valence-band offsets of InGaZnO <sub>4</sub> , LaAlO <sub>3</sub> , and SrTiO <sub>3</sub> heterostructures explained by interface-induced gap states. <i>Journal of Materials Science: Materials in Electronics</i> , 2018, 29, 19607-19613.	1.1	1
2	Electronic Properties of Semiconductor Interfaces. <i>Springer Handbooks</i> , 2017, , 1-1.	0.3	5
3	Explanation of the barrier heights of graphene Schottky contacts by the MIGS-and-electronegativity concept. <i>Journal of Applied Physics</i> , 2016, 120, 104501.	1.1	13
4	On the band-structure lineup at Ga <sub>2</sub> O <sub>3</sub> , Gd <sub>2</sub> O <sub>3</sub> , and Ga <sub>2</sub> O <sub>3</sub> (Gd <sub>2</sub> O <sub>3</sub> ) heterostructures and Ga <sub>2</sub> O <sub>3</sub> Schottky contacts. <i>Journal of Materials Science: Materials in Electronics</i> , 2016, 27, 1444-1448.	1.1	13
5	On selenium p-n heterojunctions and Schottky contacts. <i>Journal of Materials Science: Materials in Electronics</i> , 2015, 26, 1097-1101.	1.1	1
6	On the band-structure lineup at Schottky contacts and semiconductor heterostructures. <i>Materials Science in Semiconductor Processing</i> , 2014, 28, 2-12.	1.9	22
7	On the alleviation of Fermi-level pinning by ultrathin insulator layers in Schottky contacts. <i>Journal of Applied Physics</i> , 2012, 111, .	1.1	44
8	Branch-point energies and the band-structure lineup at Schottky contacts and heterostructures. <i>Journal of Applied Physics</i> , 2011, 109, 113724.	1.1	70
9	Interface-induced gap states and band-structure lineup at TiO <sub>2</sub> heterostructures and Schottky contacts. <i>Journal of Applied Physics</i> , 2010, 107, 013706.	1.1	13
10	On the explanation of the barrier heights of InP Schottky contacts by metal-induced gap states. <i>Applied Physics Letters</i> , 2008, 93, .	1.5	22
11	On the electric-dipole contribution to the valence-band offsets in semiconductor-oxide heterostructures. <i>Applied Physics Letters</i> , 2007, 91, .	1.5	44
12	Electronic Properties of Semiconductor Interfaces. , 2006, , 147-160.		1
13	Slope parameters of the barrier heights of metal-organic contacts. <i>Applied Physics Letters</i> , 2006, 88, 112116.	1.5	32
14	Comment on "Band gap and band offset of (GaIn)(PSb) lattice matched to InP" [Appl. Phys. Lett. 87, 032102 (2005)]. <i>Applied Physics Letters</i> , 2006, 89, 126101.	1.5	0
15	On the band structure lineup at interfaces of SiO <sub>2</sub> , Si <sub>3</sub> N <sub>4</sub> , and high- $\hat{\epsilon}$ dielectrics. <i>Applied Physics Letters</i> , 2005, 86, 122101.	1.5	30
16	On the band structure lineup of ZnO heterostructures. <i>Applied Physics Letters</i> , 2005, 86, 162101.	1.5	40
17	Electronic Properties of Semiconductor Interfaces. <i>Springer Series in Surface Sciences</i> , 2004, , .	0.3	179
18	Semiconductor Surfaces and Interfaces. <i>Springer Series in Surface Sciences</i> , 2001, , .	0.3	328

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19	Barrier heights of real Schottky contacts explained by metal-induced gap states and lateral inhomogeneities. <i>Journal of Vacuum Science &amp; Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena</i> , 1999, 17, 1867.	1.6	400
20	Comment on "A study on barrier height in Al <sub>x</sub> Ga <sub>1-x</sub> N Schottky diodes in the range 0 ≤ x ≤ 0.2" by M. R. H. Khan, H. Nakayama, T. Detchprohm, K. Hiramatsu and N. Sawaki in <i>Solid-State Electronics</i> , 1997 41, 287. <i>Solid-State Electronics</i> , 1998, 42, 470-471.	0.8	0
21	Valence-band offsets and Schottky barrier heights of layered semiconductors explained by interface-induced gap states. <i>Applied Physics Letters</i> , 1998, 72, 1899-1901.	1.5	73
22	Calculation of valence-band offsets of lattice-matched GaInTIP/InP heterostructures and of Schottky barrier heights of metal-GaN contacts. <i>Applied Physics Letters</i> , 1997, 71, 1231-1233.	1.5	4
23	Oxidation of clean and H-terminated SiC surfaces. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , 1997, 46, 366-369.	1.7	28
24	Elementary calculation of the branch-point energy in the continuum of interface-induced gap states. <i>Applied Surface Science</i> , 1997, 117-118, 380-387.	3.1	33
25	Barrier heights of GaN Schottky contacts. <i>Applied Surface Science</i> , 1997, 117-118, 388-393.	3.1	67
26	Empirical tight-binding calculation of the branch-point energy of the continuum of interface-induced gap states. <i>Journal of Applied Physics</i> , 1996, 80, 5076-5082.	1.1	163
27	Chemical trends of barrier heights in metal-semiconductor contacts: on the theory of the slope parameter. <i>Applied Surface Science</i> , 1996, 92, 367-371.	3.1	103
28	Electronic properties of ideal and interface-modified metal-semiconductor interfaces. <i>Journal of Vacuum Science &amp; Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena</i> , 1996, 14, 2985.	1.6	70
29	Schottky contacts on ternary compound semiconductors: Compositional variations of barrier heights. <i>Applied Physics Letters</i> , 1995, 67, 2209-2211.	1.5	17
30	<i>Semiconductor Surfaces and Interfaces</i> . Springer Series in Surface Sciences, 1995, , .	0.3	282
31	Metal-semiconductor contacts: electronic properties. <i>Surface Science</i> , 1994, 299-300, 928-944.	0.8	202
32	Barrier Heights of 3C- and 6H-SiC Schottky Contacts: Explanation by the MIGS- and "Electronegativity Model. , 1994, , 169-174.		4
33	Mechanisms of barrier formation in schottky contacts: Metal-induced surface and interface states. <i>Applied Surface Science</i> , 1990, 41-42, 128-138.	3.1	18
34	Mechanisms of Barrier Formation in Schottky Contacts. NATO ASI Series Series B: Physics, 1989, , 11-38.	0.2	6
35	Chemical trends in Schottky barriers: Charge transfer into adsorbate-induced gap states and defects. <i>Physical Review B</i> , 1988, 37, 7129-7132.	1.1	74
36	Mechanisms of Schottky-barrier formation in metal-semiconductor contacts. <i>Journal of Vacuum Science &amp; Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena</i> , 1988, 6, 1270.	1.6	111

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37	Deep Levels at Compound-Semiconductor Interfaces. NATO ASI Series Series B: Physics, 1988, , 253-287.	0.2	0
38	On the oxidation of III-V compound semiconductors. Surface Science, 1986, 168, 577-593.	0.8	53
39	On the present understanding of Schottky contacts. Festkörperprobleme, 1986, , 67-88.	0.7	18
40	Electronic properties and chemical interactions at III-V compound semiconductor surfaces: Germanium and oxygen on GaAs(110) and InP(110) cleaved surfaces. Applications of Surface Science, 1985, 22-23, 705-723.	1.0	25
41	On the surface physics of III-V compound semiconductors. , 1984, , 229-268.		3
42	Electronic characterization of compound semiconductor surfaces and interfaces. Thin Solid Films, 1983, 104, 285-299.	0.8	28
43	On the correlation of geometrical structure and electronic properties at clean semiconductor surfaces. Surface Science, 1977, 63, 79-95.	0.8	53
44	Über die charakteristische Temperatur? R abschreckend kondensierter Metallschichten. European Physical Journal A, 1962, 170, 93-104.	1.0	8
45	Messung der Fehlorderungsenergie an abschreckend kondensiertem Kupfer bei tiefer Temperatur. European Physical Journal A, 1959, 157, 149-158.	1.0	17